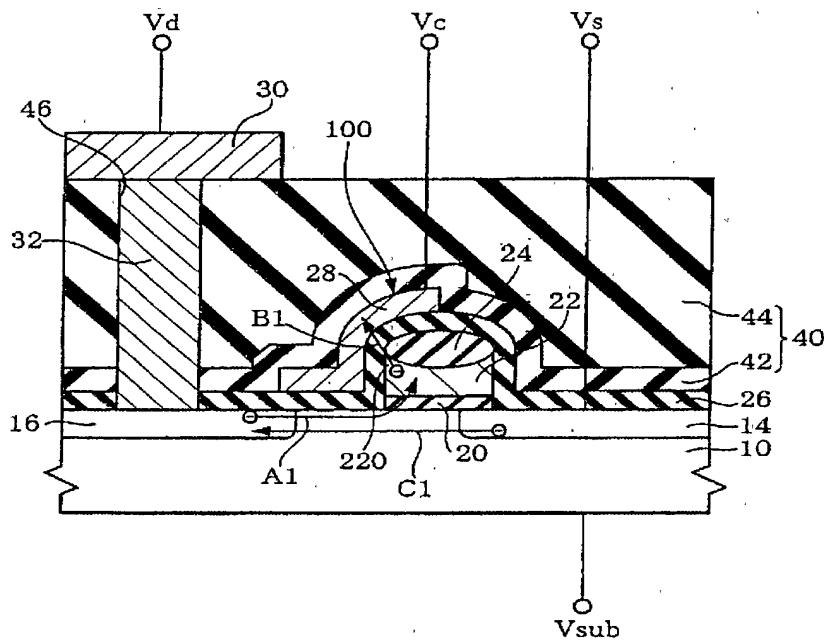


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Fig. 1



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Fig. 2 (a)

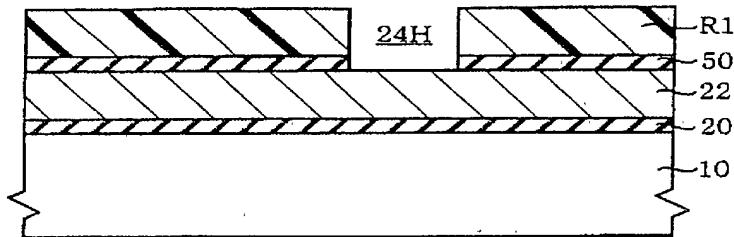


Fig. 2 (b)

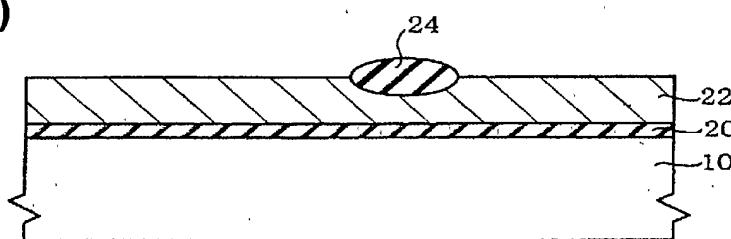
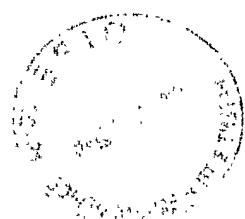
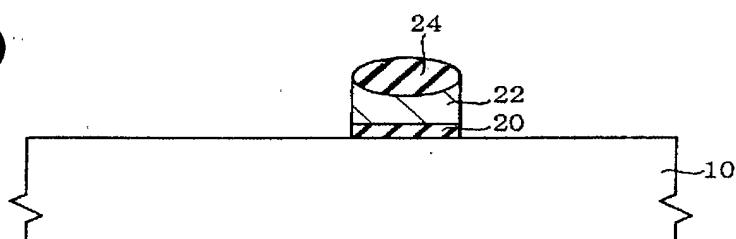


Fig. 2 (c)



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Fig. 3 (a)

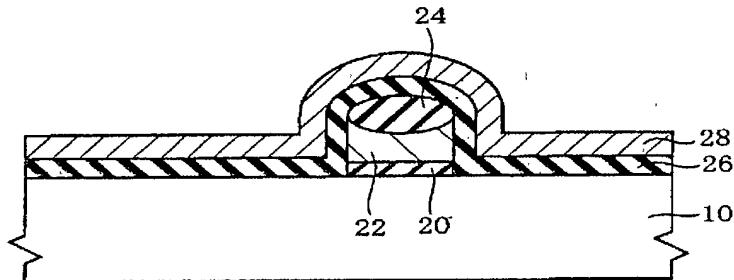
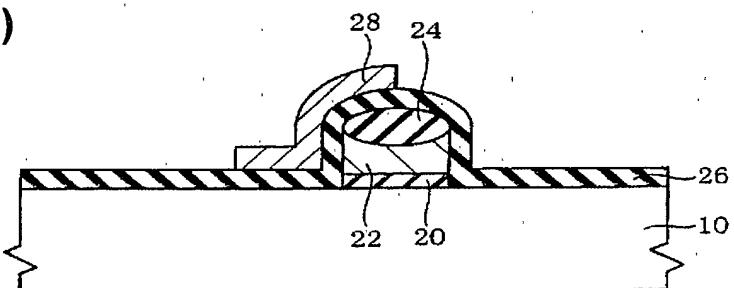


Fig. 3 (b)



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Fig. 4 (a)

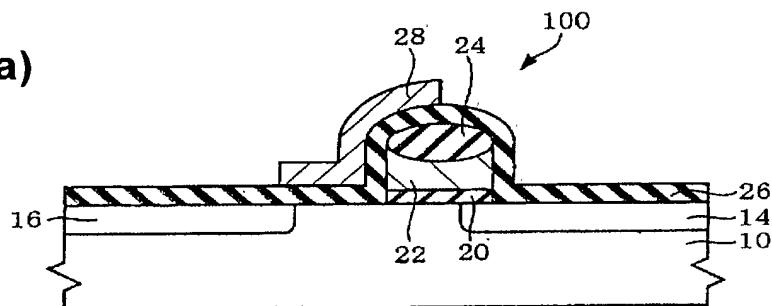
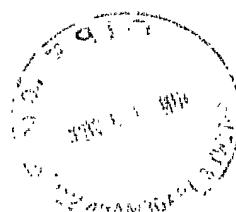
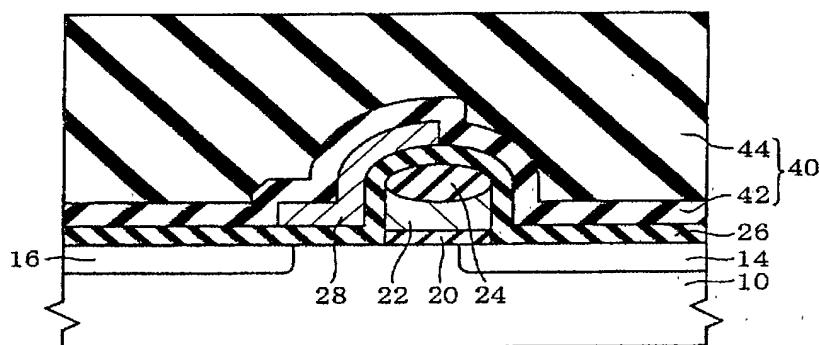


Fig 4 (b)



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Fig. 5

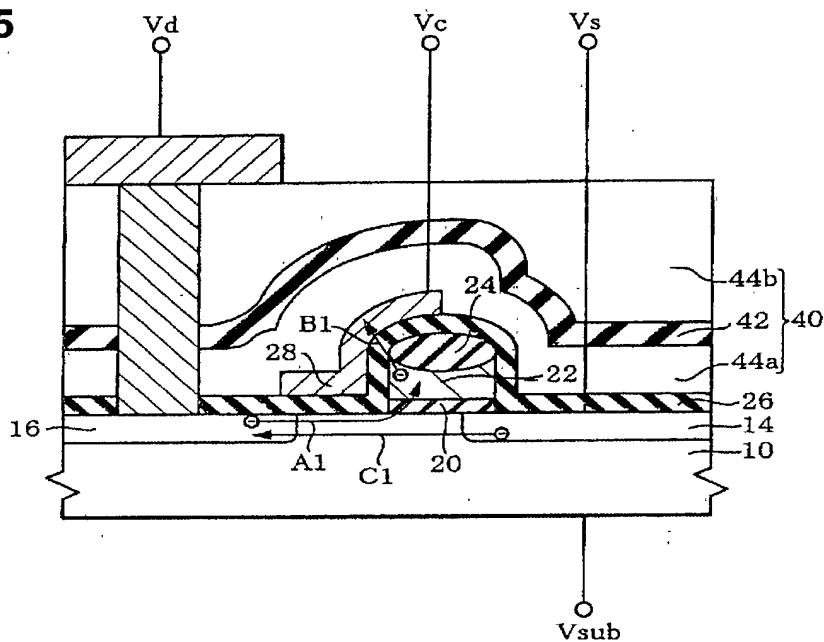


Fig. 6

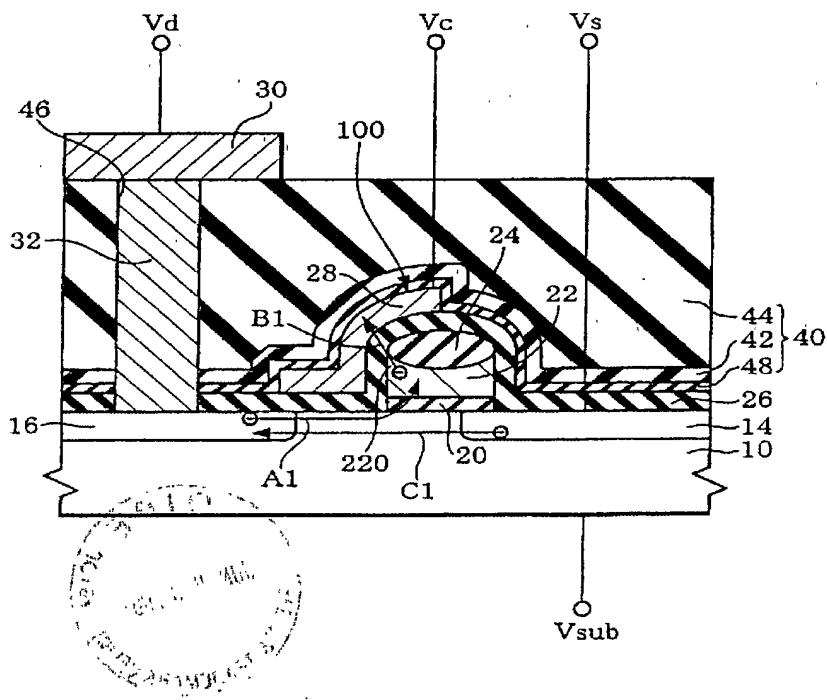


Fig. 7

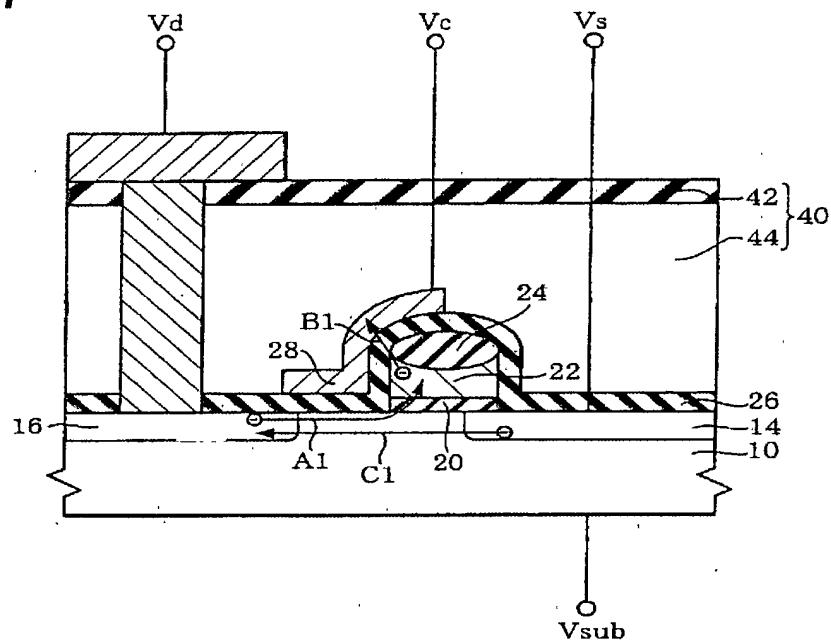
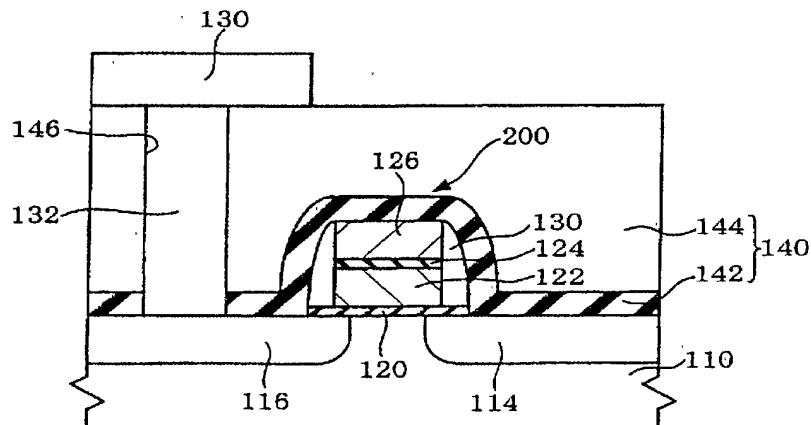


Fig. 8



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Fig. 9 (a)

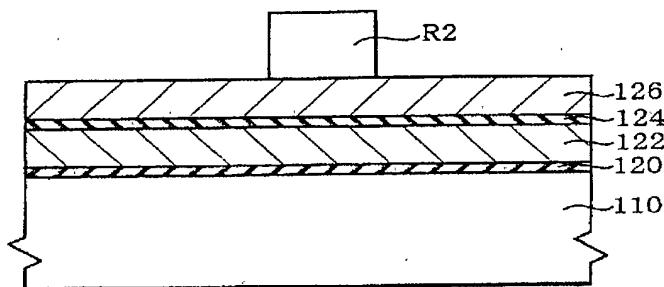
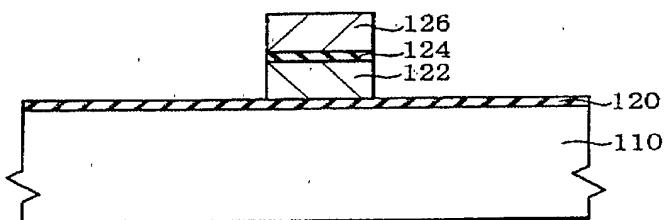


Fig. 9 (b)



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Fig. 10 (a)

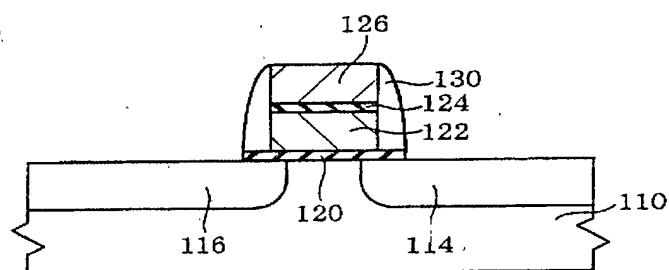


Fig. 10 (b)

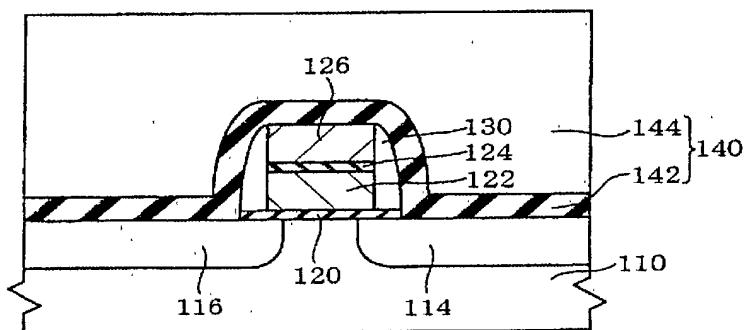
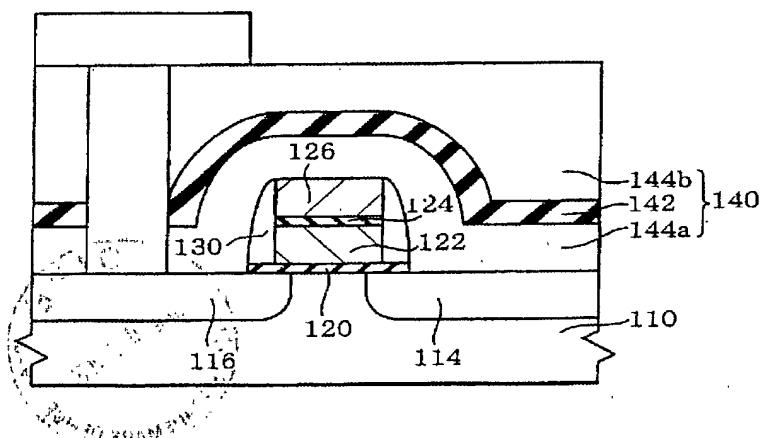


Fig. 11



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Fig. 12

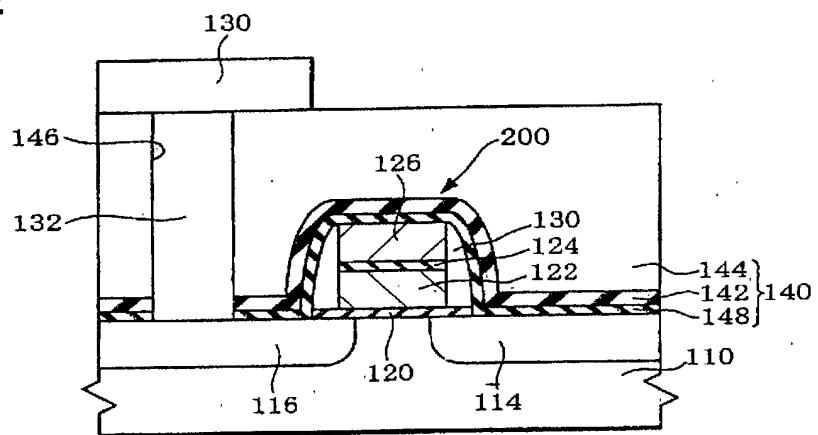
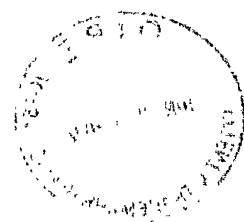
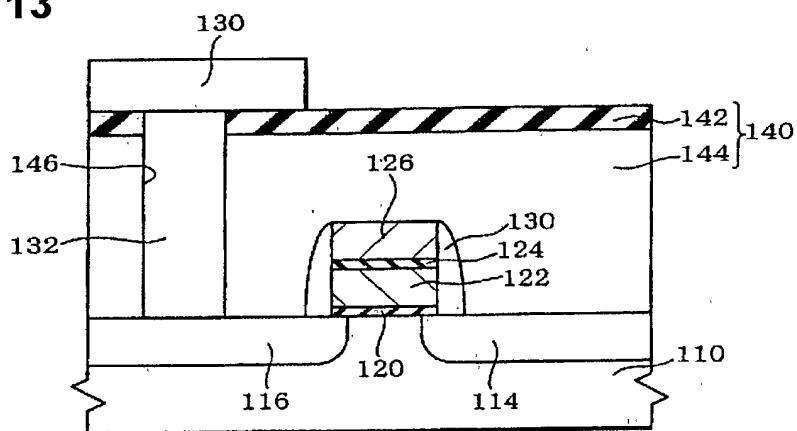


Fig. 13



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Fig. 14

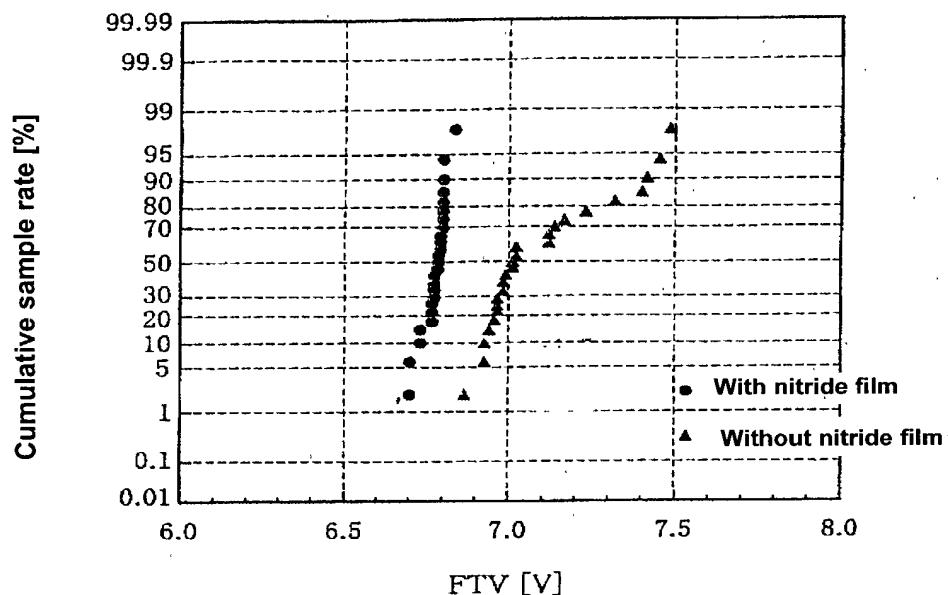
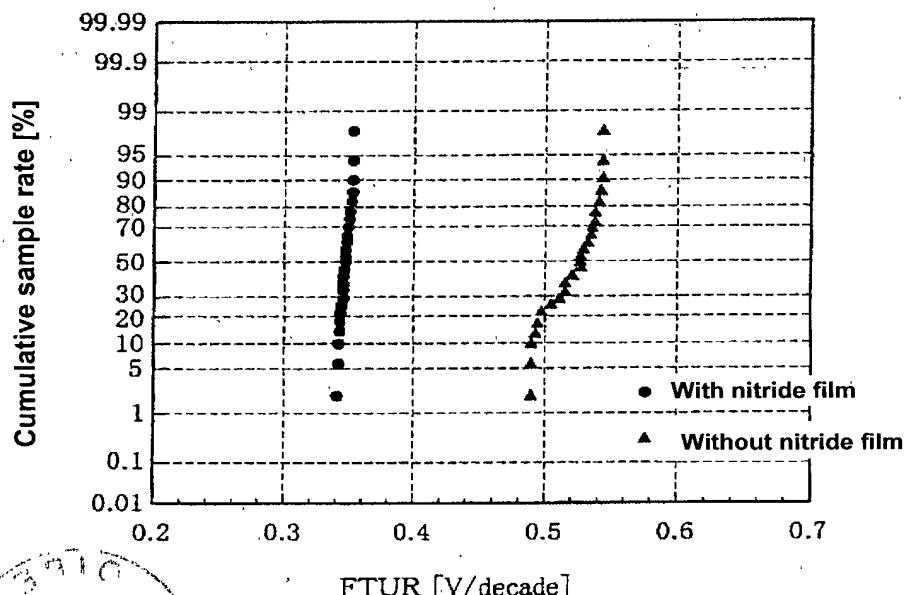


Fig. 15



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Fig. 16

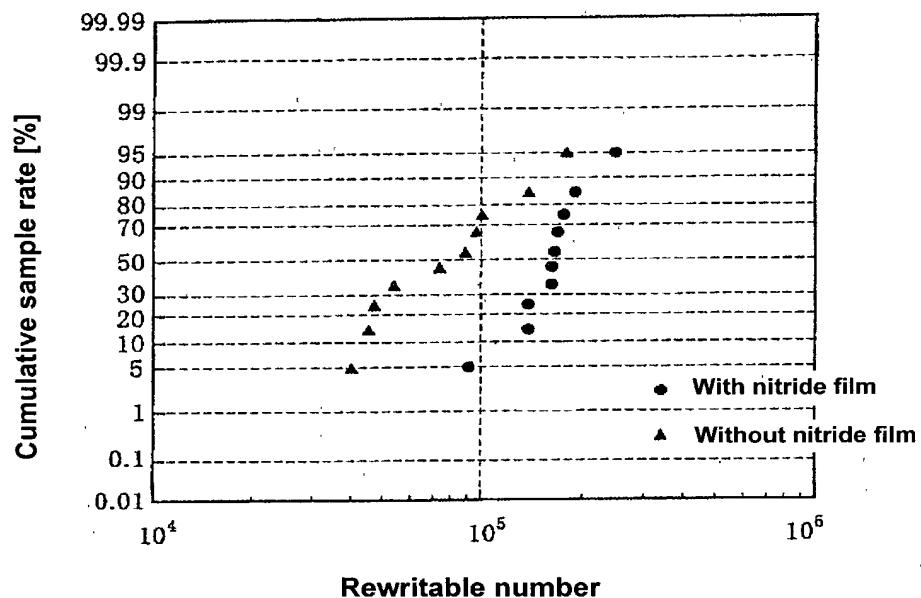
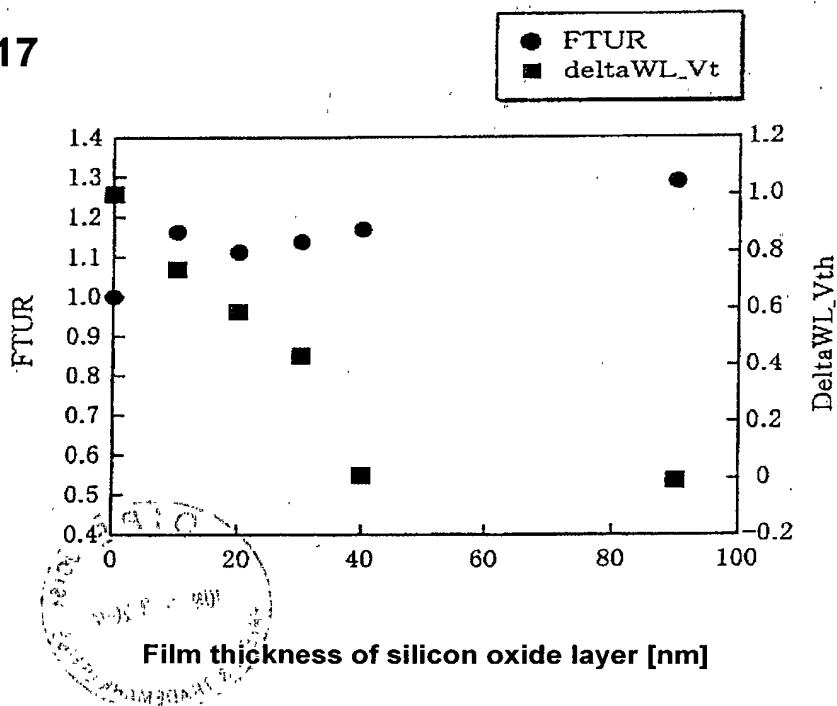


Fig. 17



Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

Inventor: Tomoyuki Furuhata et al

Atty. Ref. No.: 9319S-000328

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Fig. 18

